

INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Application Number	10/038,745
		Filing Date	January 2, 2002
		First Named Inventor	Robert Jackson
		Group Art Unit	1754
		Examiner Name	Ngoc Nguyen
Sheet	1	of	1
Attorney Ref. Number			

NON-PATENT LITERATURE DOCUMENTS

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Sheet	1	of 1	Attorney Ref. Number	FOC1100-1			
U.S. PATENT DOCUMENTS							
Examiner Initials	Cite No.	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Passages or Figures Appear	
		Number	Kind Code (if known)				
Ng	A53	US-6080530	--	06/27/00	Shao et al.		
Ng	A54	US-6143191	--	11/07/00	Baum et al.		
		US-					
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FOREIGN PATENT DOCUMENTS					Publication Date MM-DD-YYYY (Number 43)	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Passages or Figures Appear
Examiner Initials	Cite No.	Country Code	Number	Kind Code (if known)			
Ng	B6	EP	1052466	A1	11/15/00	Ebara Corp.	
Examiner Signature	Ngoc Ng Nguyen			Date Considered	12/09/04		

ATTY DOCKET NO.:	FOC1100-1	SERIAL NO.:	10/038,745
APPLICANT(S): Robert Jackson		AUG 15 2002	
FILING DATE:	January 2, 2002	GROUP ART UNIT:	1754
PATENT NO. OF PARENT: n/a		ISSUE DATE OF PARENT: n/a	

**SUPPLEMENTAL INFORMATION
DISCLOSURE STATEMENT BY
APPLICANT**

AUG 15 2002

U.S. PATENT DOCUMENTS

EXAM. INITIALS	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE	
mp	A24	2,879,212	03/24/59	Hill, et al.	204	60	12/19/55
	A25	3,146,179	08/25/64	Davies	204	60	03/15/62
	A26	3,684,667	08/15/72	Sayce	204	60	07/27/70
	A27	4,125,443	11/14/78	Grant, et al.	204	60	09/29/77
	A28	4,176,018	11/27/79	Faron, et al.	204	60	11/03/78
	A29	4,312,718	01/26/82	Watanabe, et al.	204	60	06/20/80
	A30	4,900,395	02/13/90	Syverson, et al.	156	639	04/07/89
	A31	4,960,488	10/02/90	Law, et al.	156	643	12/19/89
	A32	5,002,632	03/26/91	Loewenstein, et al.	156	643	11/22/89
	A33	5,298,112	03/29/94	Hayasaka, et al.	156	643	12/15/92
	A34	5,378,324	01/03/95	Hodgson	204	60	04/02/93
	A35	5,405,491	04/11/95	Shahvandi, et al.	156	643	03/04/94
	A36	5,597,495	01/28/97	Keil, et al.	216	66	11/07/94
	A37	5,705,080	01/06/98	Leung, et al.	216	67	07/06/94
	A38	5,762,813	06/09/98	Takiyama, et al.	216	67	03/13/96
	A39	5,846,886	12/08/98	Hattori, et al.	438	740	02/28/97
	A40	5,849,639	12/15/98	Molloy, et al.	438	714	11/26/97
mp	A41	5,872,061	02/16/99	Lee, et al.	438	705	10/27/97
	A42	5,880,031	03/09/99	Wong	438	706	06/25/92

EXAMINER	DATE CONSIDERED
<i>Nguyen</i>	12/09/04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

FORM PTÖ 1449 US Department of Commerce
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**SUPPLEMENTAL INFORMATION
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PATENT NO. OF PARENT: n/a	ISSUE DATE OF PARENT: n/a

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<i>TRADEMARK</i>	A43	5,880,032	03/09/99	Doi, et al.	438	706	07/30/96
<i>lyn</i>	A44	5,888,309	03/30/99	Yu	134	1.2	12/29/97
	A45	5,904,566	05/18/99	Tao, et al.	438	689	06/09/97
	A46	5,935,874	08/10/99	Kennard	438	710	03/31/98
	A47	5,970,376	10/19/99	Chen	438	637	12/29/97
	A48	5,980,769	11/09/99	Yanagisawa, et al.	216	67	11/06/97
	A49	6,007,733	12/28/99	Jang, et al.	216	80	05/29/98
	A50	6,024,887	02/15/00	Kuo, et al.	216	48	06/03/97
	A51	6,024,888	02/15/00	Watanabe, et al.	216	73	11/13/96
<i>lyn</i>	A52	6,051,505	04/18/00	Chu, et al.	438	710	03/05/98

FOREIGN PATENT DOCUMENTS

EXAM. INITIALS	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION (YES/NO)
	B1					
	B2					

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages)

C1	
C2	

EXAMINER <i>mgz-lyn wong</i>	DATE CONSIDERED <i>12/09/04</i>
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Robert Jackson

TC 1700
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PATENT NO. OF PARENT:
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ISSUE DATE OF PARENT
n/a

INFORMATION DISCLOSURE
STATEMENT BY APPLICANT

JUL 2 3 2002

U.S. PATENT DOCUMENTS

EXAM. INITIALS		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
<i>YJW</i>	A1	3,976,447	8/24/76	Merchant, et al.	55	71	3/11/75
	A2	4,960,488	10/2/90	Law, et al.	156	643	12/19/89
	A3	5,207,836	5/4/93	Mei Chang	134	1	6/3/92
	A4	5,336,832	8/9/94	Alfred E. Keller	585	710	11/6/92
	A5	5,549,802	8/27/96	Xin S. Guo	204	298.11	10/24/94
	A6	5,565,038	10/15/96	Ethan Ashley	134	2	5/16/91
	A7	5,685,916	11/11/97	Ye, et al.	134	1.1	7/7/95
	A8	5,756,400	5/26/98	Ye, et al.	438	710	12/8/95
	A9	5,788,778	8/4/98	Shang, et al.	134	1	9/16/96
	A10	5,788,799	8/4/98	Steger, et al.	156	345	6/11/96
	A11	5,844,195	12/1/98	Fairbairn, et al.	219	121.43	11/18/96
	A12	6,020,035	2/1/00	Gupta, et al.	427	534	10/29/96
	A13	6,029,718	2/29/00	Jackson, et al.	141	231	6/26/98
	A14	6,109,206	8/29/00	Maydan, et al.	118	723IR	5/29/97
	A15	6,159,333	12/12/00	Gupta, et al.	156	345	10/8/98
	A16	6,255,222	7/3/01	Xia, et al.	438	710	8/24/99
	A17	6,264,852	7/24/01	Herchen, et al.	216	60	6/16/00
	A18	6,271,148	8/7/01	Kao, et al.	438	727	10/13/99
<i>YJW</i>	A19	6,352,081	3/5/02	Lu, et al.	134	22.1	7/9/99

EXAMINER

Nguyen

DATE CONSIDERED

12/09/02

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APPLICANT(S):	ROBERT JACKSON
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PATENT NO. OF PARENT:	1754
n/a	n/a
ISSUE DATE OF PARENT	

INFORMATION DISCLOSURE
STATEMENT BY APPLICANT

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JUL 23 2002
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<i>YJ</i>	A20	6,379,531	4/23/02	Chandran, et al.	134	1.1	2/4/99
	A21	6,379,575	4/30/02	Yin, et al.	216	67	10/21/97
	A22	6,387,288	5/14/02	Bjorkman, et al.	216	67	4/21/00
<i>YJ</i>	A23	2002/0074013A1 09/741,529	published 6/20/02	Shang, et al.	134	1.1	12/19/00

FOREIGN PATENT DOCUMENTS

EXAM. INITIALS	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION (YES/NO)
<i>YJ</i>	B1 EP0697467A1	21.02.1996	Europe	C23C	16/44	Yes
	B2 WO 99/06611	11.02.1999	WO	C23C	16/44	Yes
	B3 WO 99/28538	10.06.1999	WO	C25B	9/00	Yes
	B4 EP0965661A2	22.12.1999	Europe	C25B	9/00	Yes
<i>YJ</i>	B5 EP1076355A2	14.02.2001	Europe	H01L	21/00	Yes

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages)

<i>YJ</i>	C1	Kinetics of Gaseous Fluorine Reactions, by Rudy Toon and Myron Kaufman. Progress in Reaction Kinetics, 1975, Vol. 8, No. 2, pp. 81-93
<i>YJ</i>	C2	VLSI Technology, Sze, Section 8.3 - Dry Etching, McGraw-Hill Book Co., pp. 312-317 (1983)
<i>YJ</i>	C3	MKS ASTeX® Products Announces ASTRON®e Ser High Flow Reactive Gas Generators for Process Chamber Cleaning Applications, Information printed from website www.astex.com/prastrone.html (2001)

EXAMINER	<i>Myron Jackson</i>	DATE CONSIDERED	<i>12/01/04</i>
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